| 4. (Currently amended) [The test system of claim 3] A test system comprising: |
|---|
| automated test equipment that includes: |
| a computer that is configured to execute a sequence of test operations for |
| testing a device-under-test, and |
| an interface circuit, operably coupled to the computer, that is configured to |
| transmit test signals in dependence upon the sequence of test operations that are executed |
| by the computer; and |
| a preconditioning monolithic integrated circuit chip, operably coupled to the |
| automated test equipment, that is configured to receive the test signals, and to generate |
| therefrom at least one preconditioned test signal that is communicated to the device- |
| under-test; wherein the preconditioning monolithic integrated circuit chip is immediately |
| juxtaposed with the device-under-test, and includes at least one contact point that is |
| arranged to provide direct contact to the device-under-test for communicating the at least |
| one preconditioned test signal to the device-under-test; and |
| a probe card, upon which the preconditioning integrated circuit is mounted, that |
| facilitates coupling of the preconditioning integrated circuit to the automated test |
| equipment, wherein the probe card is configured to provide for the mounting of a |
| plurality of preconditioning integrated circuits, thereby facilitating simultaneous testing |
| of a plurality of devices-under-test. |
| |
| 5. (Currently amended) [The test system of claim 1, wherein] A test system comprising: |
| automated test equipment that includes: |
| a computer that is configured to execute a sequence of test operations for |
| testing a device-under-test, and |
| an interface circuit, operably coupled to the computer, that is configured to |
| transmit test signals in dependence upon the sequence of test operations that are executed |
| by the computer; and |
| a preconditioning monolithic integrated circuit chip, operably coupled to the |
| automated test equipment, that is configured to receive the test signals, and to generate |
| therefrom at least one preconditioned test signal that is communicated to the device- |
| under-test: |

| wherein |
|---|
| the preconditioning monolithic integrated circuit chip is immediately juxtaposed |
| with the device-under-test, and includes at least one contact point that is arranged to |
| provide direct contact to the device-under-test for communicating the at least one |
| preconditioned test signal to the device-under-test; and |
| the at least one contact point includes a bonding pad upon which a resilient |
| structure is bonded to facilitate the direct contact to the device-under-test. |
| |
| 6. The test system of claim 5, wherein |
| the resilient structure includes a bonding wire that is bonded to two substantially |
| adjacent points on the preconditioning integrated circuit. |
| |
| 7. (Currently amended) [The test system of claim 1, wherein] A test system comprising: |
| automated test equipment that includes: |
| a computer that is configured to execute a sequence of test operations for |
| testing a device-under-test, and |
| an interface circuit, operably coupled to the computer, that is configured to |
| transmit test signals in dependence upon the sequence of test operations that are executed |
| by the computer; and |
| a preconditioning integrated circuit, operably coupled to the automated test |
| equipment, that is configured to receive the test signals, and to generate therefrom at least |
| one preconditioned test signal that is communicated to the device-under-test; |
| wherein |
| the preconditioning integrated circuit is located in immediate proximity to the |
| device-under-test, and includes at least one contact point that is arranged to provide direct |
| contact to the device-under-test for communicating the at least one preconditioned test |
| signal to the device-under-test; and |
| the preconditioning integrated circuit includes at least one of: |
| a filter, |
| an oscillator, |
| a mixer, |

an amplifier, an analog-to-digital converter, a digital-to-analog converter, a voltage source, a current source, an attenuator, a detector, a gain control, and a signal conditioner.

BEST AVAILABLE COPY

| 8. (Currently amended) [The test system of claim 1, | wherein] A test system comprising: |
|---|--|
| automated test equipment that includes: | |
| a computer that is configured to exec | ute a sequence of test operations for |
| testing a device-under-test, and | |
| an interface circuit, operably coupled | to the computer, that is configured to |
| transmit test signals in dependence upon the sequence | |
| by the computer; and | |
| a preconditioning integrated circuit, operably | coupled to the automated test |
| equipment, that is configured to receive the test sign. | |
| one preconditioned test signal that is communicated | |
| wherein | |
| the preconditioning integrated circuit is locate | ed in immediate proximity to the |
| levice-under-test, and includes at least one contact p | |
| contact to the device-under-test for communicating t | he at least one preconditioned test |
| signal to the device-under-test; and | |
| the preconditioning integrated circuit is confi | gured to measure at least one of: |
| power, | |
| phase, | |
| noise, | |
| transients, | |
| undershoots, and | |
| - | |

overshoots.

| 9. (Currently amended) [The test system of claim 1, wherein] A test system comprising: |
|---|
| automated test equipment that includes: |
| a computer that is configured to execute a sequence of test operations for |
| testing a device-under-test, and |
| an interface circuit, operably coupled to the computer, that is configured to |
| transmit test signals in dependence upon the sequence of test operations that are executed |
| by the computer; and |
| a preconditioning integrated circuit, operably coupled to the automated test |
| equipment, that is configured to receive the test signals, and to generate therefrom at least |
| one preconditioned test signal that is communicated to the device-under-test; |
| wherein |
| the preconditioning integrated circuit is located in immediate proximity to the |
| device-under-test, and includes at least one contact point that is arranged to provide direct |
| contact to the device-under-test for communicating the at least one preconditioned test |
| signal to the device-under-test; and |
| the preconditioning integrated circuit includes calibration circuitry that facilitates |
| a calibration of the preconditioning integrated circuit by the automated test equipment. |
| 10. (Currently amended) [The test system of claim 1, wherein] A test system comprising: |
| automated test equipment that includes: |
| a computer that is configured to execute a sequence of test operations for |
| testing a device-under-test, and |
| an interface circuit, operably coupled to the computer, that is configured to |
| transmit test signals in dependence upon the sequence of test operations that are executed |
| by the computer; and |
| a preconditioning integrated circuit, operably coupled to the automated test |
| equipment, that is configured to receive the test signals, and to generate therefrom at least |
| one preconditioned test signal that is communicated to the device-under-test; |
| wherein |

| the preconditioning integrated circuit is located in immediate proximity to the |
|---|
| device-under-test, and includes at least one contact point that is arranged to provide direct |
| contact to the device-under-test for communicating the at least one preconditioned test |
| signal to the device-under-test; |
| the preconditioned test signal is a high-frequency signal[,]; and |
| the preconditioning integrated circuit is configured to provide this high-frequency |
| preconditioned test signal based on a low-frequency test signal of the test signals that are |
| transmitted from the interface circuit. |
| |
| 11. Cancel. |
| |
| 12. (Currently amended) [The preconditioning integrated circuit of claim 11,] A |
| preconditioning monolithic integrated circuit chip comprising: |
| a plurality of conditioning elements, |
| each conditioning element includes circuitry that facilitates a conditioning |
| of a test signal that is communicated from an automated test equipment, to form a |
| conditioned test signal that is communicated to a device-under-test, and |
| <u>wherein</u> |
| the preconditioning monolithic integrated circuit chip is configured to be |
| immediately juxtaposed with the device-under-test when the conditioned test signal is |
| communicated to the device-under-test; wherein |
| the plurality of conditioning elements are located within the preconditioning |
| integrated circuit independent of the device-under-test. |
| |
| 13. (Currently amended) [The preconditioning integrated circuit of claim 11,] \underline{A} |
| preconditioning monolithic integrated circuit chip comprising: |
| a plurality of conditioning elements, |
| each conditioning element includes circuitry that facilitates a conditioning |
| of a test signal that is communicated from an automated test equipment, to form a |
| conditioned test signal that is communicated to a device-under-test, and |
| wherein |

the preconditioning monolithic integrated circuit chip is configured to be immediately juxtaposed with the device-under-test when the conditioned test signal is communicated to the device-under-test; further including

contact points that are configured to provide direct contact to the device-undertest for effecting communication between the preconditioning <u>monolithic</u> integrated circuit <u>chip</u> and the device-under-test, wherein

the preconditioning monolithic integrated circuit chip comprises:

a lower set of layers that include the plurality of conditioning elements,

and

an upper set of layers that include the contact points; and the lower set of layers is formed independent of the device-under-test.

14. The preconditioning integrated circuit of claim 13, wherein the contact points are:

placed on the integrated circuit during a final fabrication stage to conform to a mirror image of contact elements on the device-under-test, and connected to select conditioning elements during the final fabrication stage.

- 15. The preconditioning integrated circuit of claim 14, wherein each of the contact points includes a bonding pad upon which a resilient structure is bonded to facilitate a direct contact to the device-under-test.
- 16. The preconditioning integrated circuit of claim 15, wherein the resilient structure includes a bonding wire that is bonded to two substantially adjacent points on the preconditioning integrated circuit.
- 17. A method of testing, comprising:

programming an automated test equipment to execute a sequence of test operations for testing a device-under-test via a transmission of test signals to a preconditioning monolithic integrated circuit chip, and

providing the preconditioning monolithic integrated circuit chip that is configured to receive the test signals, and to generate therefrom at least one preconditioned test signal that is communicated to the device-under-test via a connection to the device-under-test with the preconditioning monolithic integrated circuit chip being immediately juxtaposed with the device-under-test.

18. (Currently amended) [The method of claim 17,] A method of testing, comprising:

programming an automated test equipment to execute a sequence of test
operations for testing a device-under-test via a transmission of test signals to a

preconditioning monolithic integrated circuit chip, and

providing the preconditioning monolithic integrated circuit chip that is configured
to receive the test signals, and to generate therefrom at least one preconditioned test
signal that is communicated to the device-under-test via a connection to the device-undertest with the preconditioning monolithic integrated circuit chip being immediately
juxtaposed with the device-under-test; further including

providing a configurable integrated circuit that includes a plurality of conditioning elements, each conditioning element including circuitry that facilitates a conditioning of an input signal to form a conditioned test signal, and

configuring the configurable integrated circuit to produce the preconditioned monolithic integrated circuit chip via a connection of at least one of the test signals as the input signal of at least one conditioning element of the plurality of conditioning elements, such that the conditioned test signal of the at least one conditioning element forms the preconditioned test signal that is communicated to the device-under-test.

19. (Currently amended) [The method of claim 17,] A method of testing, comprising:

programming an automated test equipment to execute a sequence of test
operations for testing a device-under-test via a transmission of test signals to a
preconditioning monolithic integrated circuit chip, and

providing the preconditioning monolithic integrated circuit chip that is configured
to receive the test signals, and to generate therefrom at least one preconditioned test
signal that is communicated to the device-under-test via a connection to the device-under-

test with the preconditioning monolithic integrated circuit chip being immediately juxtaposed with the device-under-test; wherein

providing the preconditioning monolithic integrated circuit chip includes

providing a probe card that includes a plurality of preconditioning

monolithic integrated circuit chips, thereby facilitating simultaneous testing of a plurality

of devices-under-test.

| 20. (Currently amended) [The method of claim 17,] A method of testing, comprising: |
|--|
| programming an automated test equipment to execute a sequence of test |
| operations for testing a device-under-test via a transmission of test signals to a |
| preconditioning monolithic integrated circuit chip, and |
| providing the preconditioning monolithic integrated circuit chip that is configured |
| to receive the test signals, and to generate therefrom at least one preconditioned test |
| signal that is communicated to the device-under-test via a connection to the device-under- |
| test with the preconditioning monolithic integrated circuit chip being immediately |
| juxtaposed with the device-under-test; wherein |
| a section of the sect |

the preconditioning <u>monolithic</u> integrated circuit <u>chip</u> is configured to measure at least one of:

power,
phase,
noise,
transients,
undershoots, and
overshoots.

REMARKS

The Office Action of 09/30/2003 has been carefully considered. In response thereto, the claims have been amended as set forth above. Reconsideration and allowance